

Alfven™

RF Arc Detector and Pulse Monitor



For comprehensive RF pulse monitoring, Arc detection and categorisation

The Alfven is an advanced, all-in-one diagnostic instrument for plasma arc detection and RF pulse monitoring. The Alfven architecture enables real-time processing of RF measurements with one microsecond resolution. It is designed to detect and characterise arcs while simultaneously monitoring every RF pulse to check that each pulse is within a predefined specification. Arcs and misfiring RF pulses can lead to wafer defects, therefore, the Alfven is an essential tool for rapid troubleshooting and 24/7 monitoring.

Key Features



1 µs resolution for arcs and atypical pulses simultaneously (with adjustable noise filter).



Configurable arc and pulse classification widgets.



Monitors ON-time, pulse frequency and duty cycle of every pulse.



Reports on deviations from user configured acceptance limits.



ON-OFF and multi-level pulsing (up to 3 levels).



Max., min. and average voltage and current reported during pulses to monitor "overshoot".



"Snapshot" function to view pulse profile at a given time.



Recipe function to instruct the sensor to adjust settings automatically to follow complex, multi-step plasma processes.

Key Benefits & Applications



Quickly determine if arcs or atypical pulses are responsible for wafer defects.



Pulse snapshot feature avoids inconvenient directional coupler-to-oscilloscope setup.



Monitor average pulse frequency and duty cycle of each process step with the recipe feature.



Monitor the number of arcs per process, which can lead to undesirable particle creation.



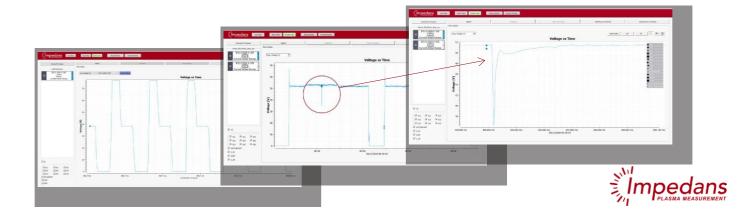
On-board, intelligent data processing – microsecond data reported when requested.



On-board memory to store data during network outage.



Generates summary reports for your process.



Model Specifications

Model#	Fwd Power Range*	Frequency Range*	Connector Interface
02-0260-01	1.5 W - 12 kW	400 kHz - 121 MHz	QC Type
02-0496-01	1.5 W - 12 kW	400 kHz - 121 MHz	B6N Multicontact Socket
02-0497-01	1.5 W - 12 kW	400 kHz - 121 MHz	B20N Multicontact Socket
02-0498-01	1.5 W - 12 kW	400 kHz - 121 MHz	B20N Multicontacts
02-0499-01	3 W -30 kW	400 kHz - 121 MHz	EIA 1-5/8"
02-0500-01	9 W - 90 kW	400 kHz - 121 MHz	EIA 3-1/8"

General Specifications

Sensor Characteristic Impedance	50 Ohms as standard
RF Connectors	QC, EIA and custom options
RF Power Range @ 50 Ohms impedance	Standard: 12 kW typical (connector dependent) High Power: 30 kW & 90 kW
Operating Temperature Range	10° C - 80° C, calibrated versus temperature
Sensor Power Requirements	15-24 V DC, 0.5 A
Communication Interfaces	Micro USB, RJ45x2
Connectivity (Impedans Software)	USB 2.0, Ethernet
Communication Protocols (Standard)	USB 2.0, HTTP Web Service
Communication Protocols (OEM Options)	EtherCAT, EtherNet/IP
Parameter Report Rate	10 Samples/second
Onboard Data Storage	14 hours of average data plus up to 5000 atypical pulse or arc events

Voltage & Current Specifications

Voltage Range (Typical)	0.3 V to $1850V_{pk}$, custom available
Voltage Resolution	0.1 V _{RMS}
Current Range	2.5 mA _{RMS} to 9 A _{RMS} , custom available
Current Resolution	2.5 mA _{RMS}
Voltage & Current Accuracy	Uncalibrated

Arc & Pulse Monitoring Specifications

Arc Duration Detection Range	1 µs to 5000 µs
Arc Amplitude Range (vs Moving Average)	1% to 100% change
Arc Categories (customisable)	9 (3 time duration ranges x 3 amplitude ranges)
Pulse Frequency Detection Range	5 Hz to 100 kHz
Pulse Level Monitoring	Upto 3 levels (Ex. Power high, Medium, Off)
Pulse Timing Resolution	1 µs
Pulse Parameters Reported	Pulse frequency, Duty cycle (of each pulse level), Average, Max & min voltage and Current in each level
Max. Number of Recipe Steps	40 steps

^{*}Custom options available















